

501.39082X00

# 9 / DS  
9-2-03  
et al.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: UNO, et al.

Serial No.: 09/646,671

Filed: September 20, 2000

For: METHOD OF FABRICATING SEMICONDUCTOR  
INTEGRATED CIRCUIT DEVICE

Group: 2815

Examiner: E. Lee

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR 1.97 & 1.98

Commissioner or Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 25, 2003

Sir:

Pursuant to Applicants' duty of disclosure, enclosed please find copies of documents to be considered by the Examiner during examination of the above-identified application. Also enclosed is a Form, substantially equivalent to Form PTO-1449, listing the enclosed documents.

This Information Disclosure Statement is being submitted subsequent to the Office Action mailed July 30, 2003, which includes a restriction requirement, but prior to a first Office Action on the merits in the above-identified application. Accordingly, the present submission of this Information Disclosure Statement satisfies requirements of 37 CFR 1.97(b).

In view of the foregoing, it is respectfully submitted that all applicable requirements of 37 CFR 1.97 and 1.98 have been satisfied, in connection with each of the documents listed on the enclosed Form. Accordingly,

RECEIVED  
AUG 26 2003  
TECHNOLOGY CENTER 2800

consideration of the listed documents, upon examination of the above-identified application, is respectfully requested.

To the extent necessary, Applicants petition for an extension of time under 37 CFR § 1.136. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to the Deposit Account No. 01-2135 (Case No. 501.39082X00) and please credit any excess fees to such Deposit Account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP



William I. Solomon  
Registration No. 28,565

1300 North Seventeenth Street  
Suite 1800  
Arlington, VA 22209  
Tel.: 703-312-6600  
Fax.: 703-312-6666

WIS/slk  
Enclosures